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CONFIRMATION NO. 1583

<b>SERIAL NUMBER</b> 10/506,493	<b>FILING OR 371(c) DATE</b> 09/03/2004 <b>RULE</b>	<b>CLASS</b> 117	<b>GROUP ART UNIT</b> 1722	<b>ATTORNEY DOCKET NO.</b> 39.045
<b>APPLICANTS</b> Akihiko Namba, Itami-shi, Hyogo, JAPAN; Takahiro Imai, Itami-shi, Hyogo, JAPAN; Hisao Takeuchi, Itami-shi, Hyogo, JAPAN;				
<b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP03/16492 12/22/2003				
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2002-379229 12/27/2002				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after allowance Verified and Acknowledged		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 1	<b>TOTAL CLAIMS</b> 15
Examiner's Signature _____ Initials _____		<b>INDEPENDENT CLAIMS</b> 2		
<b>ADDRESS</b> 29453				
<b>TITLE</b> Low-resistance n type semiconductor diamond and process for producing the same				
<b>FILING FEE RECEIVED</b> 920	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	